



#0404

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APPLICANT:	
Cecile BERNE et al.	
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LIST OF REFERENCES CITED BY APPLICANT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
EJ	AA	5,877,070	3/1999	Goesele et al.	438	458	
EJ	AB	6,303,468	10/2001	Aspar et al.	438	455	
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
EJ	AG	FR 2767416 w/ English Abstract	2/1999	France	6,303,468	corresponding	X	Abstract
	AH							
	AI							
	AJ							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

EJ	AK	B. Aspar et al: XP001050558 "The Generic Nature Of The Smart-Cut Process For Thin Film Transfer", Journal Of Electronic Materials, Vol. 30, No. 7, 22 , pp. 834-840, (2001)
EJ	AL	B. Aspar et al: XP000884996, "Smart-Cut Technology: An Industrial Application Of Ion Implementation Induced Cavities", Materials Research Society Symposium Proceedings, Materials Research Society, Vol. 510, No. 13, pp 381-393 (19998)
	AM	

EXAMINER
DATE CONSIDERED

4-28-05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.